



App. No.09/757,583
Docket: 033082.065

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor: Matsudo

Group Art Unit: 2823

Application No.: 09/757,583

Examiner: Brairton, Scott A

Filing Date: 01/11/2001

For: METHOD FOR DEPOSITING TUNGSTEN SILICIDE FILM AND METHOD FOR
PREPARING GATE ELECTRODE/WIRING

RESPONSE TO OFFICE ACTION

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RECEIVED
DEC 29 2003
TECHNOLOGY CENTER 2800

A response to the Office Action mailed June 19, 2003 is being timely filed with a
three month extension of time.

REMARKS begin on page 2 of this paper.